


<b>Search Notes</b> 	<b>Application/Control No.</b> 10720056	<b>Applicant(s)/Patent Under Reexamination</b> CHA, KI CHUL
	<b>Examiner</b> JASON HECKERT	<b>Art Unit</b> 1792

SEARCHED			
Class	Subclass	Date	Examiner

SEARCH NOTES		
Search Notes	Date	Examiner
Updated Search	1/29/2008	JMH
Updated Search	11/17/2008	JMH

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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